



IFW

PATENT  
Customer No. 22,852  
Attorney Docket No. 04329.3132

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
Masahiro Kiyotoshi	)	Group Art Unit: 2814
Application No.: 10/653,209	)	Examiner: Cao, Phat X.
Filed: September 3, 2003	)	Confirmation No.: 2572
For: SEMICONDUCTOR DEVICE AND	)	
METHOD OF MANUFACTURING SAME	)	

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**RESPONSE TO RESTRICTION REQUIREMENT**

In the Office Action mailed October 12, 2004, with a period for response extending through November 12, 2004, the Examiner required restriction under 35 U.S.C. § 121 between the following groups of claims:

Group I - Claims 1-10, characterized by the Examiner as drawn to a semiconductor device; and

Group II - Claims 11-20, characterized by the Examiner as drawn to a process of making a semiconductor device.

Applicant provisionally elects to prosecute the group characterized by the Examiner as Group I, claims 1-10, without traverse.

Please grant any extensions of time required to enter this response and charge any additional required fees to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: November 9, 2004

By: Rajeev Gupta  
Rajeev Gupta  
Reg. No. 55,873